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Attorney Docket SEL 195

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Yamazaki et al.)
)
Serial No.: 09/610,753)
)
Filed: July 6, 2000)
)
For: Semiconductor Device And)
Manufacturing Method Thereof)
)
Art Unit: 2815)
)
Examiner: P. Brock III)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

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Shannon Wallace

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Signature

Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT F

Sir:

In response to the Office Action of January 20, 2004, a two month extension of time being submitted herewith, please amend the above-identified application as follows: